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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

JP2004/015598 PCT/PTO 20 APR 2006

In re application of :
Seiji AKITA et al. : **Mail Stop: PCT**
Serial No. NEW : Attorney Docket No. 2006_0598A
Filed April 20, 2006 :

NANOSIZE HEATER-MOUNTED
NOZZLE AND METHOD FOR
MANUFACTURING SAME AND
METHOD FOR FORMING MICRO
THIN FILM

[Corresponding to PCT/JP2004/015598
Filed October 21, 2004]

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
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PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to examination of the above-referenced U.S. patent application please
amend the application as follows:

ATTACHMENT E